



Docket No.: 230421US26YA



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

ATTORNEYS AT LAW

RE: Application Serial No.: 10/673,501
Applicants: Andrej S. MITROVIC
Filing Date: September 30, 2003
For: SYSTEM AND METHOD FOR USING FIRST-PRINCIPLES
SIMULATION TO CHARACTERIZE A SEMICONDUCTOR
MANUFACTURING PROCESS
Group Art Unit: 2128
Examiner: Akash Saxena

SIR:

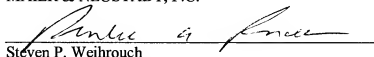
Attached hereto for filing are the following papers:

REPLY BRIEF

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of \$0.00 to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Steven P. Weihrouch

Registration No. 32,829

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)
(OSMMN 10/08)

Ronald A. Rudder, Ph.D.
Registration No. 45,618

I:\ATTY\RAR\REPLY BRIEF\230421US\SHORT PTO COVER SHEET 1-14-09.DOC